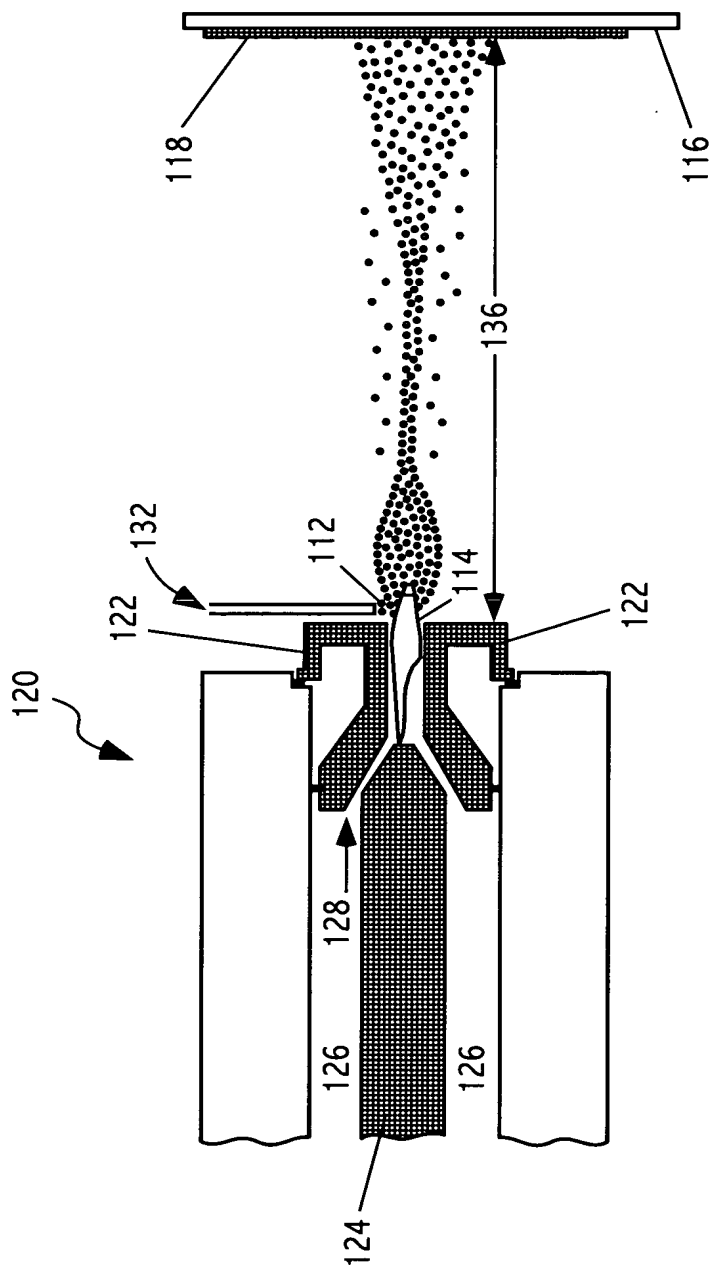




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TITLE: LOW CONTAMINATION PLASMA CHAMBER
COMPONENTS AND METHODS FOR MAKING THE SAME
INVENTOR(S): CHRISTOPHER C. CHANG ET AL.
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SHEET 1 OF 4



PRIOR ART
FIG. 1



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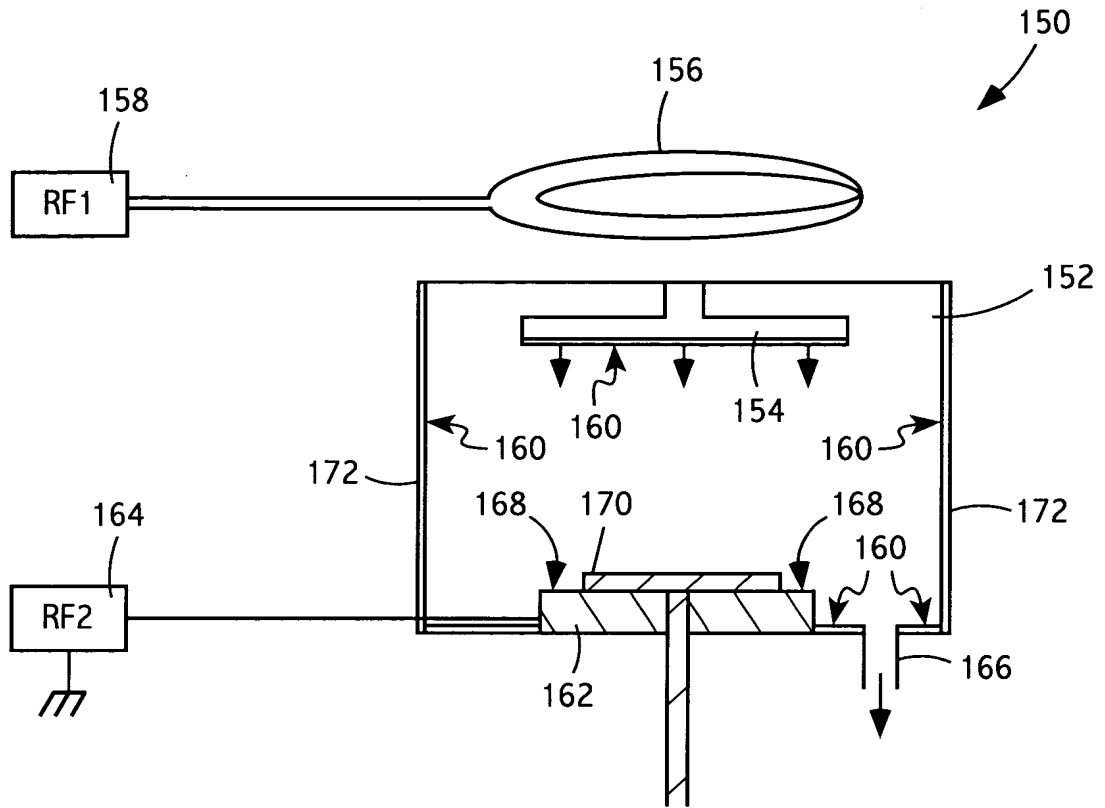


FIG. 2



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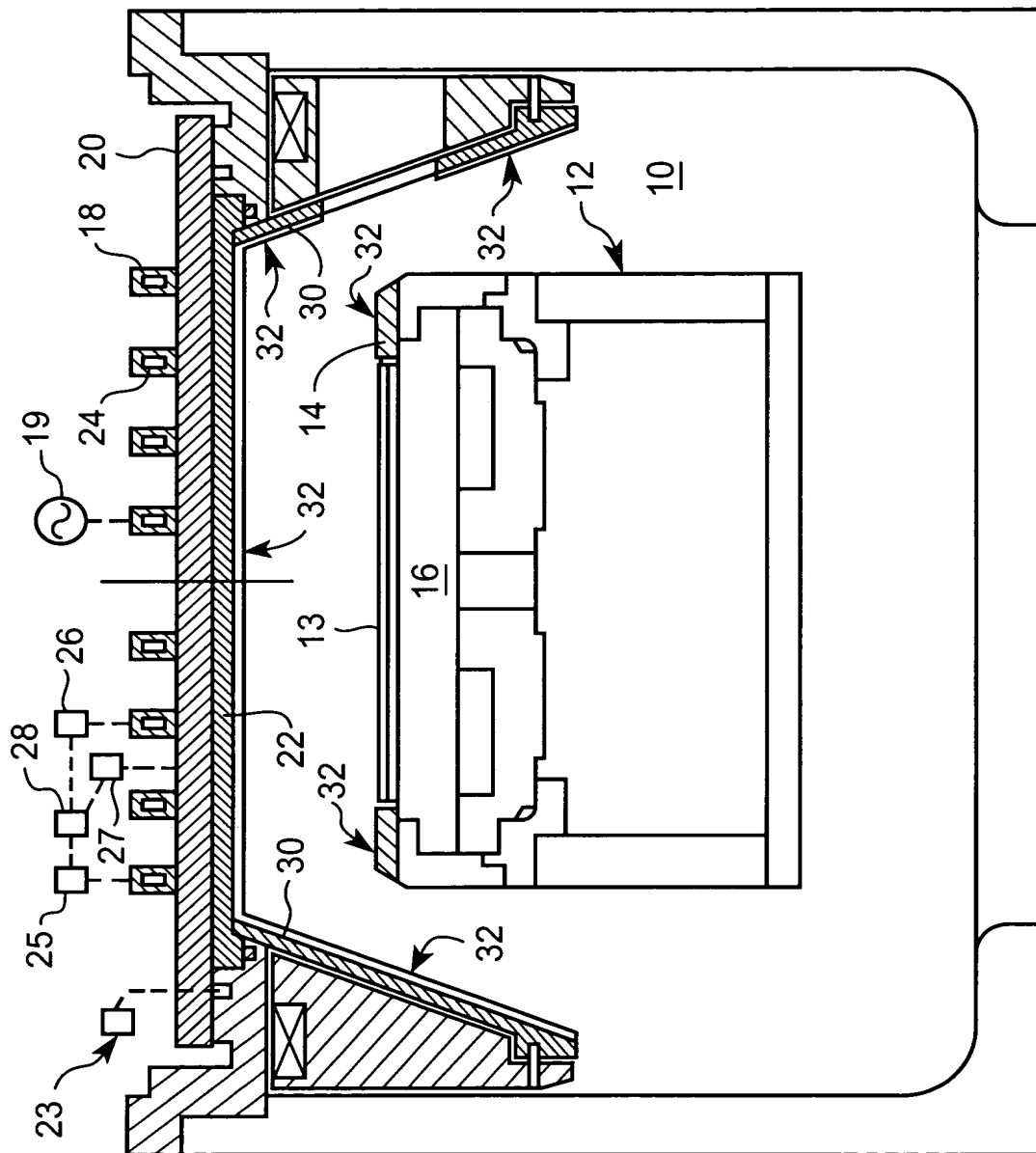


FIG. 3



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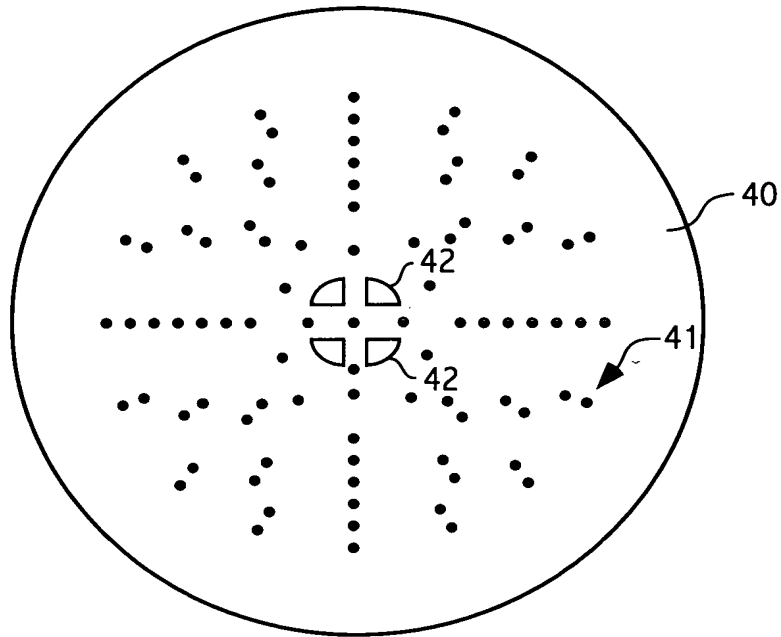


FIG. 4